

Obducat receives order for NIL system from Spanish university

OBDUCAT has received an order for the EITRE 3 development system for nanoimprint lithography (NIL). The order value amounts to approximately SEK 2.8 million and delivery is planned for the fourth quarter of 2025.

The university will use Obducat's EITRE 3 system in its R&D activities focusing on micro- and nanofabrication. The system enables the replication of patterns on a micro- and nanometer scale and is well suited for academic environments where flexibility and repeatability are key. This is the university's first order to Obducat.

This information is information that Obducat is obliged to make public pursuant to the EU Market Abuse Regulation. The information was submitted for publication, through the agency of the contact persons set out above, at 2025-10-16 08:30 CEST.

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About Obducat AB (publ)

Obducat AB (publ) is an innovative developer and supplier of technologies, products and processes used for the production and replication of advanced micro and nano structures. Obducat's products and services serve the demands of customers worldwide within the LED and Display, Optics and Photonics, MEMS and Sensor industries as well as in High Power and High Frequency electronics and Biomedical Devices. Obducat's technologies include nano imprint technology, resist- and wet processing technologies. Obducat has its own market presence in Sweden, Germany, Japan, USA, England, Portugal and China and the headquarter is located in Lund, Sweden. Obducat is a public company. The Obducat share is traded on the Swedish NGM Main Regulated Equity exchange. Read more at www.obducat.com or contact us via email investorrelations@obducat.com

Attachments

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